

## Electronic Patent Application Fee Transmittal

<b>Application Number:</b>	09827307			
<b>Filing Date:</b>	06-Apr-2001			
<b>Title of Invention:</b>	Plasma processing apparatus and plasma processing method			
<b>First Named Inventor/Applicant Name:</b>	Tadahiro Ohmi			
<b>Filer:</b>	E. Rico Hernandez/Febes Lazo			
<b>Attorney Docket Number:</b>	P 280043 EL00026CDC			
Filed as Large Entity				
<b>Utility      Filing Fees</b>				
<b>Description</b>	<b>Fee Code</b>	<b>Quantity</b>	<b>Amount</b>	<b>Sub-Total in USD(\$)</b>
<b>Basic Filing:</b>				
<b>Pages:</b>				
<b>Claims:</b>				
<b>Miscellaneous-Filing:</b>				
<b>Petition:</b>				
<b>Patent-Appeals-and-Interference:</b>				
<b>Post-Allowance-and-Post-Issuance:</b>				
<b>Extension-of-Time:</b>				
Extension - 2 months with \$0 paid	1252	1	460	460

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
<b>Miscellaneous:</b>				
Request for continued examination	1801	1	810	810
<b>Total in USD (\$)</b>				<b>1270</b>